

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		09/892,061	BACHUR ET AL.	
Examiner		Art Unit		Page 1 of 1
William H. Beisner		1744		

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-4,073,691	02-1978	Ahnell et al.	435/34
	B	US-4,730,112	03-1988	Wong, Jacob Y.	250/343
	C	US-4,857,735	08-1989	Noller, Hans G.	250/339.07
	D	US-6,639,678	10-2003	Veale, James R.	356/437
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title-Date, Publisher, Edition or Volume, Pertinent Pages
	U	Allen. "Diode Laser Absorption Sensors For Gas Dynamic and Combustion Flow." Measurement Science and Technology, Vol 9 (1998), No. 4, pp. 545-562.
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.